

	Anatharta Ala	Applicant(s)
	Application No.	Applicant(s)
Notice of Allowability	10/800,738	MATSUMOTO, KIMIKAZU
Notice of Allowability	Examiner	Art Unit
	Richard H. Kim	2871
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Report of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate commining IGHTS. This application is s	n this application. If not included unication will be mailed in due course. THIS
1. This communication is responsive to <u>1/30/07</u> .		
2. X The allowed claim(s) is/are 1-3 and 5-7.		•
 3. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). 	be been received. be been received in Application	on No. <u>10/096,905</u> .
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF		
INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached		
1) hereto or 2) to Paper No./Mail Date	=	(110010) alabito
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date		in the Office action of
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
 DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5 \square Notice of In	formal Patent Application
Notice of Praftperson's Patent Drawing Review (PTO-948)		ummary (PTO-413),
	Paper No.	Mail Date
 Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 	7. 🔲 Examiner's	Amendment/Comment
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material David Nel Supervisory Paten	9.	Statement of Reasons for Allowance
Technology Center 2800		

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DETAILED ACTION

Allowable Subject Matter

- 1. Claims 1-3 and 5-7 allowed.
- 2. The following is an examiner's statement of reasons for allowance: The prior art of record, taken alone or in combination, fails to teach or disclose in light of the specifications, claim 1) an active matrix type liquid crystal display device comprising a first conductive film provided on the flattening film so as to oppose the data lines via the slits, the first conductive film being set to a common electric potential with the common electrode; wherein the first conductive film overlaps the portions of the common electrode where the slits are formed; wherein the first conductive film has a width that is at least larger than a width of the portion of the black matrix; claim 5) a method of manufacturing an active matrix type liquid crystal display device, the method comprising forming a first conductive film on the flattening film, the first conductive film opposing the date lines via the slits; wherein the first conductive film overlaps the portions of the common electrode where the slits are formed; wherein the first conductive film has a width that is at least larger than a width of the portion of the black matrix.

The first conductive film (37) of Choi et al. is clearly shorter in width than the black matrix. Furthermore, in regard to the claim language "portions of the black matrix", in light of the specifications, Examiner has interpreted its meaning to be an entire segment of the black matrix as illustrated in Figure 12 as 209a.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

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fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Richard H. Kim whose telephone number is (571)272-2294. The

examiner can normally be reached on 9:00-6:30 M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, David Nelms can be reached on (571)272-1787. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would

like assistance from a USPTO Customer Service Representative or access to the automated

information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Richard H Kim Examiner Art Unit 2871

RHK

David Nelms
Supervisory Patent Examiner
Technology Center 2800